



Attorney Docket No. 0756-2332

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Takeshi FUKADA et al.

Serial No. 09/904,906

Filed: July 16, 2001

For: GLASS SUBSTRATE ASSEMBLY,
SEMICONDUCTOR DEVICE AND
METHOD OF HEAT-TREATING
GLASS SUBSTRATE

) Group Art Unit: 2825

) Examiner: L. Malsawma

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AMENDMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated July 30, 2003, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 9 of this paper.

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02 FC:1202
03 FC:1201

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